

ANALYZER SOLUTIONS FOR YOUR PROCESS!

Model 3050-SLR for Super Low Range Moisture Analysis

Quartz-crystal Microbalance Technology: Accurate. Reliable. Verifiable. Responsive.

WELCOME TO THE NEW WORLD OF PROCESS MOISTURE ANALYSIS

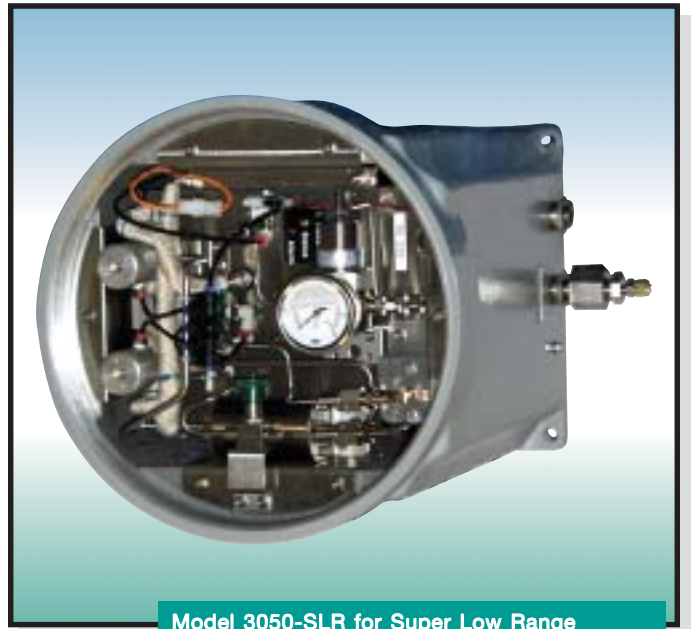
The Model 3050-SLR provides extremely accurate measurement of trace levels of moisture in a gas through the use of a quartz-crystal oscillator sample cell. AMETEK is the leader in quartz-crystal technology which, for thirty years has offered significant advantages over other measurement techniques:

- It is the most accurate trace moisture measurement technology available.
- It responds far faster to both increasing and decreasing moisture levels.
- It is specific to moisture in most applications.
- It provides a much more rugged sensor.

Because of these advantages, the quartz-crystal oscillator has become the industry standard for applications ranging from ultrahigh purity semiconductor gases to natural gas streams containing 30% H₂S. Now the 3050-SLR brings the benefits of quartz-crystal technology to a broad spectrum of low-range moisture measurement applications.

Direct Measurement of Concentration

The Model 3050-SLR measures moisture concentration directly in parts-per-million by volume, parts-per-million by weight, or mass-of-water per standard volume without additional pressure or temperature compensation. For customers who wish to convert concentration to dew/frost point, the 3050-SLR can be programmed for a live process pressure input or a fixed process pressure.



Model 3050-SLR for Super Low Range Moisture Analysis

Actual ppmv Moisture	Model 3050-SLR Accuracy	Aluminum-Oxide Accuracy ±2° C for dew points ≥ -65° C and ±3° C for below
0.1	±0.03 ppmv	+72%/-43% of reading
1	±10% of reading	+59.6%/-38.2% of reading
5	±10% of reading	+52.4%/-35.2% of reading
10	±10% of reading	+30.9%/-24.0% of reading
20	±10% of reading	+29.3%/-23.0% of reading

Dew point conversions are referenced to 14.7 psia

Accurate and Responsive

The accuracy of the 3050-SLR is an amazing ± 0.03 ppmv or $\pm 10\%$ of reading, whichever is greater, over the calibrated range of 0.1 to 2500 ppmv. Compare this to the typical accuracy of a hygrometer.

The design of the 3050-SLR enables a speed of response that is far superior to other analyzers while consuming as little as 150 sccm of sample gas. The reliability and stability of the QCM sensor completely eliminates the need for routine factory recalibration requirements. Your confidence in the analyzer's performance is assured because every 3050-SLR has the ability to self-verify the QCM sensor's responsiveness to moisture changes.

On-line Verification Ability

The 3050-SLR is equipped with the ability to self-verify its accuracy and sensitivity to moisture. With a built-in zero module and internal moisture generator, the 3050-SLR gives you data you will have confidence in. On a programmed schedule or whenever you feel it's necessary, you can route your process gas through the 3050-SLR's internal zero gas generator and its internal moisture generator, giving you a zero reference and a span calibration standard based upon the actual process gas. The 3050-SLR automatically zeroes itself then compares its moisture measurement with the NIST-traceable known value of the internal moisture generator. If necessary, the analyzer can make small corrections to its calibration automatically. If a severe calibration problem exists, the analyzer will provide an alarm. With the 3050-SLR, you will always be confident that the analyzer is responsive to the moisture present in the sample gas.



THE QUARTZ-CRYSTAL SENSOR

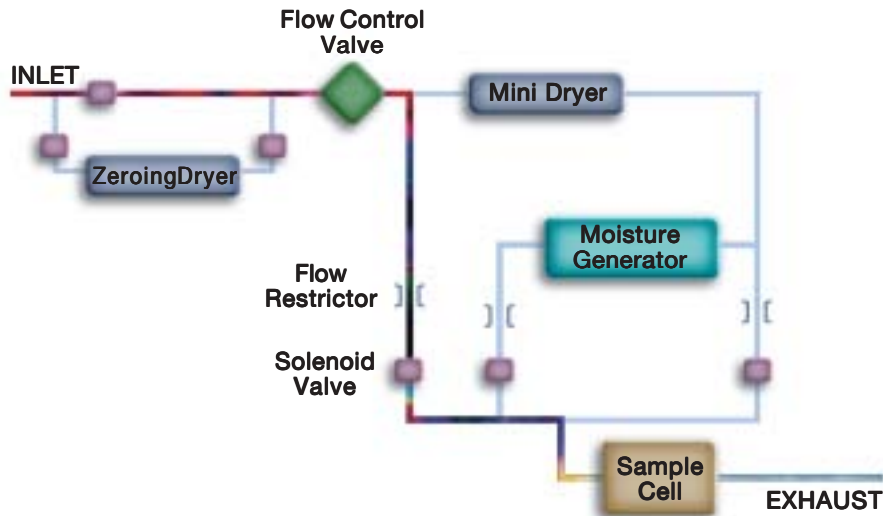
The heart of the 3050-SLR analyzer is a quartz-crystal microbalance (QCM) sensor and sampling system developed by AMETEK specifically for highly accurate moisture measurements. The sensor consists of a quartz-crystal disc coated with a hygroscopic polymer. As the amount of moisture sorbed onto the polymer varies, the mass of the QCM changes producing a corresponding change in the frequency of oscillation.

ADDITIONAL SAMPLE SYSTEM COMPONENTS

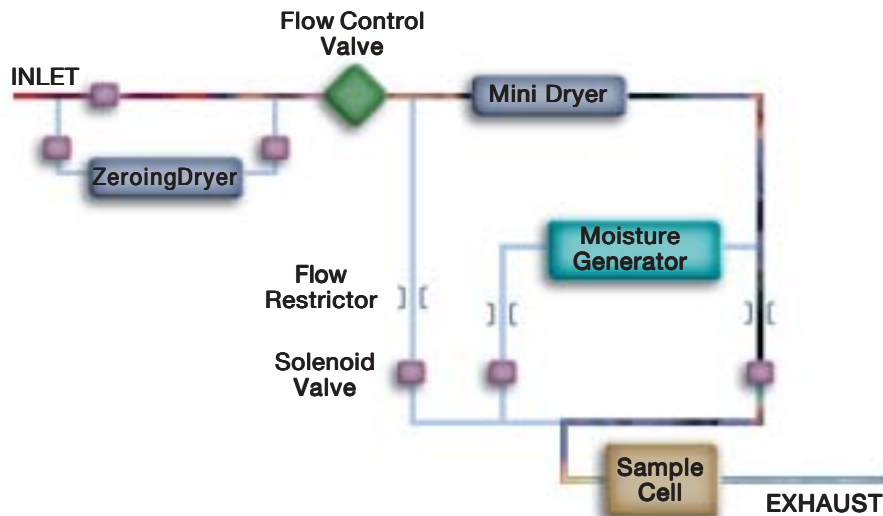
In order to derive the full advantages of the Model 3050-SLR, a well-designed sampling system is necessary. AMETEK can supply a complete sampling system to include:

- **Filters:** In-line or bypass filters to remove particulate from gas or liquid sample streams and small amounts of oil or other condensables from gas streams.
- **Pressure Reducer:** Required if sample sources are at pressures higher than 3.45 Bar (50 psi). Maximum input pressure is 200 Bar (3000 psi).
- **Heated Pressure Reducer:** Designed to prevent condensation of gases upon pressure reduction or to vaporize liquefied gas streams with boiling points not exceeding 40°C (104°F). Maximum input pressure is 200 Bar (3000 psi). Suitable for NEC/CEC Class I, Division 1, Groups B/C/D, and CENELEC IIC T3 areas.

Process Gas Cycle



Reference Gas Cycle



Non-equilibrium Operating Theory of Quartz-crystal Microbalance

Moisture sensors are notoriously slow because they need a long time to equilibrate, especially when drying down. Non-equilibrium operation is a special technique developed as a means of improving a moisture sensor's speed of response. It works by systematically cycling the sensor between the process gas and a dry reference gas.

During the process gas cycle (top, left), moisture molecules accumulate on the surface of the QCM sensor. During the reference gas cycle (bottom, left), these water molecules are swept off the surface of the sensor by the dry gas flow. Since there is no waiting for equilibrium, the system provides a measurement of moisture concentration every cycle.

The number of water molecules that accumulate on the surface of the sensor is a function of the difference in moisture between the process gas and reference gas. The analyzer compares the process gas with the known, dry reference as opposed to trying to measure an absolute value that only occurs once the equilibrium has been achieved. When a high moisture event occurs, the 3050-SLR responds quickly to alert you to the problem. After the high moisture event passes, the non-equilibrium nature of the Model 3050-SLR means that no long dry down period is ever needed before you will get accurate sub-ppmv measurements.

PERFORMANCE SPECIFICATIONS

Technology: Quartz-Crystal Microbalance

Range: 0.1 to 2500 parts-per-million by volume (ppmv).
Readout capability in ppmw, lb/mmscf, mg/Nm³, and dew point in °F or °C (requires process pressure as an input).

Reference Gas: Continuously produced using actual sample gas

On-Line Verification: Internal moisture source with NIST-traceable calibration enables on-demand verification of analyzer accuracy and responsiveness without uninstalling the analyzer. Verification function can be triggered remotely with a voltage signal.

Accuracy: ±0.03 ppmv or ±10% of reading from 0.1 to 2500 ppmv

Reproducibility: ±5.0% of reading from 0.1 to 2500 ppmv

Limits of Detection: 0.1 ppmv

Moisture Generator: 1.0 ppmv nominal, calibration is NIST-traceable

Reliability: No routine factory calibration required due to highly stable and reliable nature of QCM sensor

QCM Response Time: Near real time. Computer-enhanced response, which may lead to errors, is not required to obtain quick wet-up or dry-down response.

Sensitivity: 0.01 ppmv or 1% of reading, whichever is greater

Allowable Inlet Pressure: 1.38 to 3.45 Bar (20 to 50 psi) gauge (up to 200 Bar [3000 psi]) with optional pressure reducer; analyzer performance is independent of process pressure

Exhaust Pressure: 0 to 1 Bar (0 to 15 psi)

Sample Gas Temperature: 0° to 100° C (32° to 212° F); analyzer performance is immune to changes in sample gas temperature

Gas Flow Requirements: Approx. 150 sccm. Approx. 1.0 slpm bypass flow for increased speed of response

Outputs: Isolated 4 to 20 mA analog signal, keyboard selectable; 12 bit (0.025%) resolution, RS232 and RS485 serial communication ports

Alarms: Two contact closures: system and data valid alarms

Ambient Temperature Limits: -20° to 45° C (-4° to 113° F)

Utility Requirements

120/240 VAC, 50/60 Hz, 150 Watts

Instrument Air: 5 to 7 Bar (70 to 100 psi)

Approvals and Certifications

UL/CSA General Safety Requirements

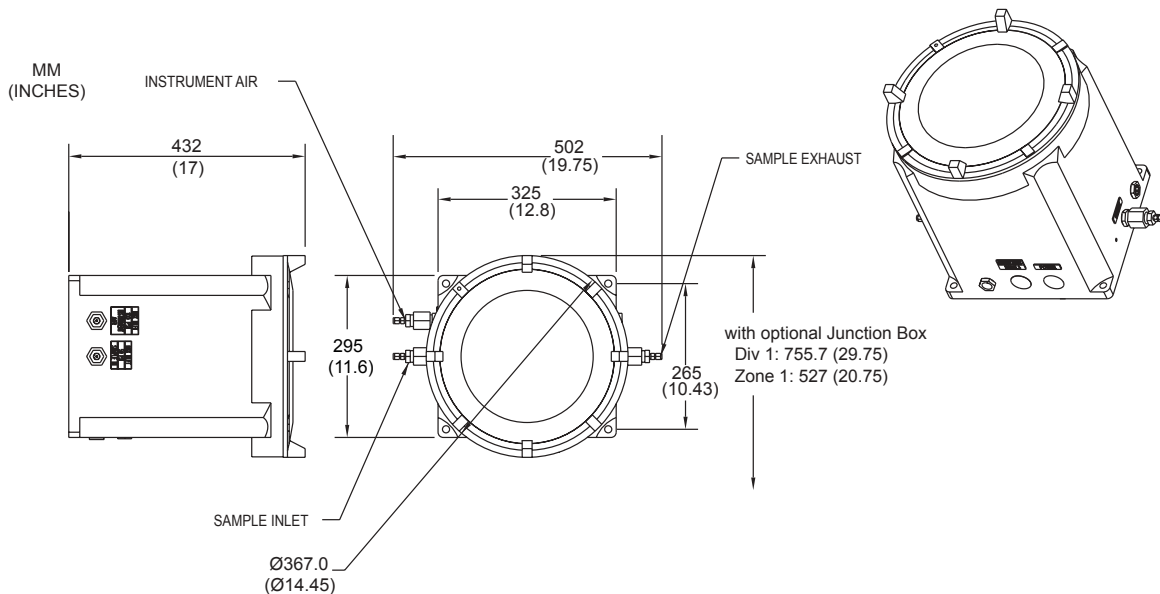
UL/CSA Class I, Division 1, Groups B, C, D T6

Complies with all relevant European directives

ATEX Directive: II 2 G EEx de IIC T6

Russian Gosstandart Pattern Approval

Russian Ex Proof Certification: 1ExdIICT6X



One of a family of innovative process analyzer solutions from AMETEK Process Instruments. Specifications subject to change without notice.

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3050-SLR (12/10/04)



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